

DOCKET NO: 245161US3CIP



IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF

TSUTOMU OKABE, ET AL.

: EXAMINER: MOORE, K.

SERIAL NO: 10/706,914

:

RCE FILED: HEREWITH

: GROUP ART UNIT: 1763

FOR: WAFER PROCESSING
APPARATUS HAVING DUST PROOF
FUNCTION

: (APPLICATION FILED: NOVEMBER
14, 2003)

AMENDMENT UNDER 37 C.F.R. § 1.114

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

In response to the Office Action dated August 22, 2005, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 4 of this paper.